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Patent
268/001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Group Art Unit: N/A
)	
Telkamp, et al.)	Examiner: N/A
)	
Serial No.: 10/046,416)	
)	
Filed: October 19, 2002)	
)	
For: 1XN OR NX1 OPTICAL LIGHT)	
SWITCH HAVING A PLURALITY)	
OF MOVEABLE LIGHT GUIDING)	
MICROSTRUCTURES)	
)	

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant hereby discloses to the Patent Office patents, publications, and other information of which they are aware. A Form PTO-1449 listing the above items for consideration by the examiner is attached hereto. One copy of each patent and publication cited is being submitted with this Statement.

The items cited on the attached Form PTO-1449 may or may not be material to the

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Dated: May 2, 2002

Valerie Cloyd
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Patent
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patentability of the claims in the above-identified application, and their submission is not to be construed as an admission that the items are material or considered to be material (37 C.F.R. § 1.97(h)), or even that they qualify as "prior art" under 35 U.S.C. § 102 with respect to the claimed invention unless specifically designated as such. Identification of any publication or patent having an issue date or a publication date after the statutory bar date is not an admission that the publication was published, or that the patent was filed, before the invention claimed in this application was made by Applicant.

The filing of this Information Disclosure Statement is not to be construed to mean that a search has been made or that additional information material to the examination of this application does not exist.

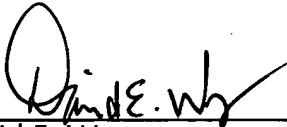
No Fee

Because this statement is being submitted prior to the first action on the merits, no fee is required under 37 C.F.R. § 1.97(b). However, should the Patent Office determine that a fee is required, the Assistant Commissioner is hereby authorized to charge Deposit Account No. 12-2475 for the fee.

Respectfully submitted,

Dated: May 2, 2002

By: _____


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268/001

10/046,416

LIST OF PATENTS AND OTHER ITEMS FOR APPLICANT'S
INFORMATION DISCLOSURE STATEMENT

APPLICANT:

Telkamp, et al.

FILING DATE:

October 19, 2001

GROUP:

N/A

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES NO
AM	EP1004910A2	5/31/2000	EP			X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

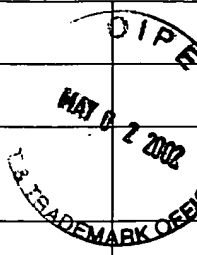
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DATE CONSIDERED:

EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant

FORM PTO-1449 LIST OF PATENTS AND OTHER ITEMS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. 268/001	SERIAL NO. 10/046,416
	APPLICANT: Telkamp, et al.	
	FILING DATE: October 19, 2001	GROUP: N/A

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